



Docket No.: 128223-1.061282.0035

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Mitsumi ITO, et al.	:	Confirmation Number: 7469
Application No.: 10/634,988	:	Group Art Unit: 2825
Filed: August 06, 2003	:	Examiner: Stacy Whitmore

For: SEMICONDUCTOR DEVICE, METHOD OF GENERATING PATTERN FOR SEMICONDUCTOR DEVICE, METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND DEVICE OF GENERATING PATTERN USED FOR SEMICONDUCTOR DEVICE

AMENDMENT

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 14, 2006, having a three-month shortened statutory period for response set to expire on October 14, 2006 (Saturday), reconsideration of the above-identified application is respectfully requested in view of the following amendment and remarks.